DISTRICT AND			
	("5948577" "5691011").pn.	US-PGPUB; USPAT; EPO;	2005/01/20 16:32
2	(*6373187*).pn.	US-PGPUB; USPAT; EPO;	2005/01/11 13:29
1	"JF 63300920 A"	JPO DEDUCINE	2005/01/11 13:36
1	"JP 06109912 A"	JPO	2005/01/11 13:37
1	*JP 06347637 A*	JPO	2005/01/11 13:38
1	"JF 07234314 A"	JPO	2005/01/11 13:39
1	*JP 09230127 A*	JPO	2005/01/11 13:39
1	"JF 11040354 A"	JPO	2005/01/11 13:44
0	*09/423969*.pn.	US-PGPUB; USPAT; EPO;	2005/01/11 14:10
0 0	*09/423969*	US-PGPUB; USPAT; EPO;	2005/01/11 14:10
1 454	1 (thin adj film) and affinity and substrate and organic and (ito or glass)	US-PGPUB; USPAT; EPO;	2005/01/28 16:33
2 211	(thin adj film) and affinity and substrate and (organic adj semiconductor) and (ito or glass)	US-PGPUB; USPAT; EPO;	2005/01/28 16:33
3 174	(thin adj film) and affinity and substrate and (organic adj semiconductor) and (ito or glass) and inorganic	US-PGPUB; USPAT; EPO;	2005/02/01 16:01
4 65	(thin adj film) and affinity and substrate and (organic adj semiconductor) and (ito or glass) and inorganic and polyimide	US-PGPUB; USPAT; EPO;	2005/01/28 16:34
5 44	(thin adj film) and affinity and substrate and (organic adj semiconductor) and (ito or glass) and inorganic and polyimide and transistor	US-PGPUB; USPAT; EPO;	2005/01/28 16:35
6 7	(thin adj film) and substrate and (affinity same (organic adj semiconductor)) and (ito or glass) and inorganic and polyimide_and_transistor	US-PGPUB; USPAT; EPO;	2005/02/01 16:01
7 570:	3 (257740,59,88,89.ccls. 438/29,30,70,99.ccls.)	US-PGPUB; USPAT; EPO;	2005/02/01 16:01
8 174	(thin adj film) and affinity and substrate and (organic adj semiconductor) and (ito or glass) and inorganic	US-PGPUB; USPAT; EPO;	2005/02/01 16:02
9 43	S17 and S18	US-PGPUB; USPAT; EPO; USPAT; EPO;	2005/02/01 16:02
1			16:02

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